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| Nota di contenuto | Layered compounds in the In ₂ O ₃ -Ga ₂ O ₃ -ZnO system and related compounds in the ternary system -- Systematic view of crystalline CAAC-IGZO and other crystalline IGZO thin films -- Fundamental properties of IGZO -- CAAC-IGZO field-effect transistor -- Device application using CAAC-IGZO. |